Synchronization of Accelerator Sub-Systems with Ultimate Precision

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MSK/DESY

- Sources of arrival time jitter
- Synchronization systems
- Low level RF controls
- Beam based feedbacks



Increasing demands on synchronization ...

... is driven by stability requirements

- \Rightarrow Bunch scale has changed from ns/ps to fs
- \Rightarrow High accelerator frequencies (e.g. CLIC)
- \Rightarrow Accelerator facility length increased ~ 100 m e.g 3.5 km

Free Electron Lasers:

- Compression control
- (self seeding) **Energy control**
- Pump-probe experiments (fs-evolution)
- External seeding (efficiency)

External injection in laser plasma wakefield

Plasma wavelength

Picosecond/femtosecond photon sources

THz / Thomson radiation

fs-synchronization pre-requisite for new accelerator applications



(exponential growth)



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RF accelerator structure

Synchronization reach into many different physics & engineering disciplines and requires wide range of know-how and technologies

Radio Frequency:

- RF Master Oscillator and distribution (cables)
- High power RF (modulator, preamp., klystron, waveguide,...)
- Low level RF

(field detection, driver, digital feedback loops,...) (reflection, cooling, phase advance,...)

Wide range of components: phase detectors / mixer / multiplier / divider / low noise amplifier / ...

Optics & Lasers:

- Laser oscillator / amplifier (phase noise, piezo resonance, pump source,...)
- Laser pulse shaping & wavelength conversion & transport
- Optical reference & distribution (fiber optics, opto-electronics, photo-detection)

Environmental control:

temperature / humidity / air pressure / vibration / ground motion / EMI / EMC

Controls & control theory:

multiple feedbacks / PLL theory / automation / SISO / MIMO / ...

Longitudinal electron beam dynamics

Arrival time of electron bunch at seed source Arrival time at entrance to undulator



Photo-cathode laserw ~ 40-60%RF phase of RF gun (non-relativistic electrons)w ~ 60-40%Seed and Pump-probe laserw ~ 100%



Arrival time of electron bunch at seed source Arrival time at entrance to undulator



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Arrival time of electron bunch at seed source Arrival time at entrance to undulator





Case 0: $E_0 \ll E_1$ and $E'_0 \ll E'_1$

$$\Sigma_{t,1}^2 = \left(\frac{R_{56}}{c_0}\right)^2 \cdot \frac{\sigma_{V_1}^2}{V_1^2} + \left(\frac{C_1 - 1}{C_1}\right)^2 \cdot \frac{\sigma_{\phi_1}^2}{\omega_{rf}^2} + \left(\frac{1}{C_1}\right)^2 \cdot \Sigma_{t,0}^2$$





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Case 1: $E_1 \ll E_2$ and $E'_1 \ll E'_2$: $\Sigma_{t,2}^2 = \left(\frac{R_{56,2}}{c_0}\right)^2 \frac{\sigma_{V_2}^2}{V_2^2} + \left(\frac{C_2 - 1}{C_2}\right)^2 \frac{\sigma_{\phi_2}^2}{\omega_{rf}^2} + \left(\frac{1}{C_2}\right)^2 \Sigma_{t,1}^2$





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Case 2: $\phi_2 \approx 0^\circ, E_2' \ll E_1'$:

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Various approaches:



Pulsed optical synchronization system



Main issue: robustness, stability and maintainability ⇒ Prototype at FLASH

- Commercial: OneFive ORIGAMI-15
- Repetition rate: 216,66MHz
- Average power: > 100mW
- Pulse duration: < 200 fs
- Mechanically robust, easy to maintain
- Phase noise ~ 5fs rms [1kHz-10MHz]









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Optical lock of two laser oscillators



Balance, background free detection





Courtesy: S. Schulz

Optical lock of two laser oscillators



Balance, background free detection



Optical lock of two laser oscillators



Balance, background free detection

input MLO (horizontal polarization) end mirror input SLO polarization-dependent (vertical polarization) beam combiner High sensitivity at low noise GD element 瓜calib = 0.014 fs/rdetector 2 "reflected" 4000 detector 1 signal (mV) 14 as/mV "forward" 2000 -/魞 OXC -2000 HT@SFG NL crystal HT@SFG -4000 HR@fundamental λ HR@fundamental λ -6000 l 500 1000 1500 2000 2500 3000 time (fs)

Courtesy: S. Schulz

- Needs: Low noise laser osc.
 - High sensitive detection
 - Fast actuator (PZT/driver)



Courtesy: S. Schulz

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Bunch Arrival Monitor



Bunch Arrival Monitor



Bunch Arrival Monitor



Example: Arrival stability at FLASH

Arrival time measurements



Typically values

60-100fs rms from injector

50-60fs rms behind BC2

40-50fs rms exit LINAC

Global slow feedback Implemented

Intra-train repetitive error correction implemented

Fast feedback reduce Bunch-to-bunch jitter ~ 20 fs





Direct conversion with photo detector (PD)

- Low phase noise (to be proven at end-station)
- Temperature drifts (0.4ps/C°)
- AM to PM conversion (0.5-4ps/W)
- Potential for improvement (corporation with PSI)





















MZI based balanced laser-to-RF phase detector

Locking low-noise microwave oscillator to laser (or visa versa) RF Oscillator $f_{vco} = n f_r$, split and delayed





MZI based balanced laser-to-RF phase detector

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RF accelerator field control system

Sketch of the controller structure

- Real-time FPGA processing of 8/16 RF channels and microsecond latency
- Generator driven Multiple-in-Multiple-out feedback controller, with adaptive feed forward drive
- Super-conducting RF cavities with ~ 300 Hz bandwidth



Precision RF field detection (noise limitation)



Non-IQ sampling field detection limited by:

- → Receiver active (< 4 fs)
- Receiver passive (< 2fs)
- LO-Generation (< 2 fs)
- → ADC (limitation) (~5 fs)

at 1.3 GHz. Can be better at high frequencies.



Measurement with ADC



Courtesy: F. Ludwig, DESY H. Schlarb, LINAC12, Tel Aviv, Israel, September 9-14, 2012



Drift compensation of microwave components

Problem:

- Mixer phase drifts ~ 0.2°/K
- Mixer amplitude drifts ~ 0.2%/K
- + dependence also on humidity
- + mixer drift not equal (one PCB)

\Rightarrow Reference tracking for mixer drift removal





Figure 3: Measured (a) amplitude and (b) phase deviation for the injected corrected signal (blue marked) and uncorrected (green marked) over 60 hours.

Courtesy: F. Ludwig, DESY



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MTCA.4 crate system used as LLRF hardware platform



MTCA.4 crate system used as LLRF hardware platform





New Beam Based Feedbacks algorithm

- Arrival FB on ACC1 only using monitors after BC1 ⇒ ~ 20 fs routine
- Arrival FB on ACC2 (was not active) Test this week ⇒ ~ 10-15 fs expected
- Ultimate: broadband NRF cavity & ultralow latency digital feedback system From simulations ⇒ ~ 5 fs expected

Courtesy: Ch. Schmidt, S. Pfeiffer, DESY

Achieved arrival time stability



Thanks you for attention





Beam Based Feedbacks:

- Arrival time (BAM) and bunch compression (BCM) after chicane BC1 are simultaneously correct amplitude and phase in ACC1 /39
- BAM and BCM after BC2 correct amplitude and phase in ACC23
- Charge measurement used for beam loading compensation

Courtesy: Ch. Schmidt, S. Pfeiffer, DESY



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Courtesy: Ch. Schmidt, S. Pfeiffer, DESY

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Fiber Link Stabilization (optically)



J. Kim et al., Opt. Lett. 32, 1044-1046 (2007)



Fiber Link Stabilization (optically)



Fiber Link Stabilization (out-of-loop)



Courtesy: F. Kaertner

Fiber Link Stabilization (optically)

3rd generation of opto-mechanics typical in loop jitter ~ 1-2 fs rms (also smaller)





Fiber Link Stabilization (optically)

Experience: Type Operate reliably Some links fast AM noise observed

Recent developments: Matching optics Retro-reflector delay line with precision stepper motor Isolation to FSD Link layout changed

Current developments 2011/12: PCB for readout electronics Low noise balanced detector Ultra-low noise LDD driver uTCA based digital FB controller

3rd generation of opto-mechanics typical in loop jitter ~ 1-2 fs rms (also smaller)



XFEL:

Dispersion management need to be improved (2 test links in 26a for 3.5km) Delay stage too short for long links and large temp. changes (PSOF fibers)

Courtesy: Bock/Schultz/Lamb